

10/585450

AP20 REG. NO. 10 07 JUL 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q89687

Shoji AKATSUKA, et al

Appln. No.: National Stage of PCT/JP2005/000031

Confirmation No.: Unknown

Group Art Unit: Unknown

Filed: July 7, 2006

Examiner: Unknown

For: GAS SENSOR PRODUCTION METHOD AND GAS SENSOR

PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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